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Notice of Allowability	Application No.	Applicant(s)	
	10/743,757 Examiner	SHIMOYAMA ET AI	<u>.                                    </u>
	Roy K. Potter	2822	
The MAILING DATE of this communication appea All claims being allowable, PROSECUTION ON THE MERITS IS (O herewith (or previously mailed), a Notice of Allowance (PTOL-85) o NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIG of the Office or upon petition by the applicant. See 37 CFR 1.313 a	OR REMAINS) CLOSED in this appropriate communication HTS. This application is subject to and MPEP 1308.	olication. If not include will be mailed in due	ed course. <b>THIS</b>
1. A This communication is responsive to the amendment of 7/29	<u>//05</u> .		
2. X The allowed claim(s) is/are <u>1-5</u> .			
a)  Acknowledgment is made of a claim for foreign priority und a)  All b)  Some* c)  None of the:  1.  Certified copies of the priority documents have be completed as a claim for foreign priority und a)  All b)  Some* c)  None of the:  1.  Certified copies of the priority documents have be completed as a claim for foreign documents have be completed as a claim for fine fine fine fine fine fine fine fine	peen received. Deen received in Application No Deen received in Application In this person of this application of this application.  Deen received in Application No Deen received in Application to file a reply of the Amendment of the Amendmen	national stage applicational stage application of the front (not the d).	quirements NOTICE OF
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Attachment(s)  1. ☑ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date  4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. Notice of Informal P 6. Interview Summary Paper No./Mail Dat 7. Examiner's Amenda 8. Examiner's Stateme 9. Other	(PTO-413), e nent/Comment	owance

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## **REASONS FOR ALLOWANCE**

The following is an examiner's statement of reasons for allowance:

The prior art does not teach or suggest the recited lead free bump of Sn-Ag with an Ag content that is lower than that of a eutectic composition of SN-Ag.

Takeda et al., U.S. Patent No. 6228322 discloses a lead free solder alloy composition that includes a rare earth element in an Sn-Ag alloy.

Muira et al., U.S. patent Application Publication US2003/0030149 A1, discloses a semiconductor device having solder bumps. The Table shown in Figure 6 includes a variety of solder compositions containing Sn-Ag, but do not disclose a Sn-Ag bump formed by a composition where the Ag content is lower than a eutectic.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Roy K. Potter whose telephone number is 571 272 1842. The examiner can normally be reached on M-F.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Roy K Potter Primary Examiner Art Unit 2822